

10/637108

Classification: 438/685.000

Status: 80 - RESPONSE AFTER FINAL ACTION FORWARDED TO EXAMINER

Title: LOW-RESISTANCE CONTACT TO SILICON HAVING A TITANIUM SILICIDE INTERFACE AND AN AMORPHO...


Examiner: LEBENTRITT, MICHAEL

Inventor: SANDHU , GURTEJ, et al

GAU: 2824

Bib Data report

**Application Title:** LOW-RESISTANCE CONTACT TO SILICON HAVING A TITANIUM SILICIDE INTERFACE AND AN AMORPHOUS TITANIUM CARBONITRIDE BARRIER LAYER

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**Examiner:** 73858 LEBENTRITT, MICHAEL (Assignment Data) **Group Art**

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**Independent Claims:** 2

▼ **Inventors:**

Last name, First name:	City:	Country or State:
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**Attorneys:** ALL **Attorney Docket No:** 3264.6US (92-0280.09/US)

**Interference No:** **Lost Case:** No **Unmatched Petition:** No **L&R Code:** 1

<b>Application Number</b> 	<b>Application No.</b> 10/637,108	<b>Applicant(s)</b> SANDHU ET AL.	

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